

Z axis | P60.Z1000S/K

Piezo Nanopositioning Stages



Introduction

P60.Z1000 piezoelectric scanning stage is a Z axis translation scanning platform. Its range is up to 1000µm, load capacity up to 1.5kg, Optional closed-loop sensor for higher positioning accuracy.

Characteristics >>

- Motion in Z
- Travel to 1000µm
- Load capacity up to 1.5kg
- Optional vacuum version

Applications >>

- Metering
- Nanopositioning
- Semiconductor technology
- Interference/scanning
- · Disc drive testing
- Quality assurance testing
- Micromachining/precision control





Technical Data >>

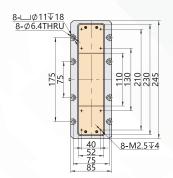
Type S-Closed loop K-Open loop	P60.Z1000S-C1	P60.Z1000K-C1	Units
Active axes	Z	Z	
Travel rang(0~120V)	800	800	μm±10%
Travel rang(0~150V)	1000	1000	μm±10%
Sensor	SGS	+	
Resolution	35	10	nm
Linearity	0.2	+	%F.S.
Repeatability	0.1	+	%F.S.
Unloaded resonant frequency	80	-	Hz±20%
Load capacity	1.5	1.5	kg
El. capacitance	72	72	μF±20%
Operating temperature ^[1]	-20~80	-20~80	℃
Material	Ti, Al	Ti, Al	
Mass (with no cable)	<1.3	<1.3	kg±20%
Vacuum	-	+	mbar
Size(L×W×H)	245×85×36	245×85×36	mm
Cable length ^[2]	1.5	1.5	m±10mm
Connector ^[2]	-	-	

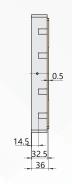
Note: Max driving voltage could be -20V~150V, 0~120V is recommended for long-term and high-reliable operation. Unless otherwise specified, the above parameters are measured at room temperature about 25° C.

- [1] Custom ultralow temperature and ultrahigh vacuum versions are available.
- [2] Custom cable length and connector is available.

Note: The parallelism of the moving platform is about $20\mu m$, and the roughness is about 1.6 to 3.2. Please contact the sales engineer for confirmation before purchase.

Drawing >>





Recommended Controllers >>



E01.D1 LCD, membrane button, up to 625mA RS-232/RS-422/USB interface Software secondary development



E53 Small size, 60mA RS-232/RS-422/USB interface Software secondary development

